

MEMS

MICROELECTROMECHANICAL SYSTEMS

CEITEC BUT, Purkyňova 123, S building, large meeting room

12–13/12/2019

**U. Schmid, M. Schneider,
G. Pfusterschmied, D. Platz**

Thursday 12/12/2019

09:15 – 11:30 Microfabrication techniques

U. Schmid

lunch break

13:00 – 15:15 Piezoelectric MEMS Materials and Devices

M. Schneider

Friday 13/12/2019

09:15 – 11:30 SiC-based MEMS for Harsh Environments

G. Pfusterschmied

lunch break

13:00 – 15:15 Modelling and Simulations of MEMS

D. Platz

(each block consist of approx. 2-hour lecture interspered with one short coffee break)



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